

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/732,763	DOI ET AL.	
Examiner	Art Unit	
Lisa C. Sievers	2863	

SEARCHED				
Class	Subclass	Date	Examiner	
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INTERFERENCE SEARCHED				
Subclass	Date	Examiner		
125	7/26/2007	LL		
	Subclass	Subclass Date		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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